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INFORMATION DISCLOSURE STATEMENT TRANSMITTAL

To Commissioner For Patents

Enclosed herewith is a Form PTO-1449, any required copies of documents listed thereon, and any concise explanation of their relevance is indicated below per 37 CFR 1.97.

Application Number	
Filing Date	
First Named Inventor	VAN BEEK, JOZEF T., M.
Group Art Unit	
Examiner Name	
Atty. Docket Number	NL03 1310 US1

	U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number NoKind Code ² (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear	
	1	us- US 2004/077119	04/22/2004	IKEDA KOICHI ET AL.		
		US-				
		US-				

	FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number (ctry³-no.⁴-kind⁵, if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of cited document	Pages, Columns Lines, Where Relevant Passages or Relevant Figures Appear	T	
	1	WO/03078299	09/25/2003	IONESCU, MIHAI ADRIAN ET AL.			
	2	WO 03/055789	07/10/2003	IKEDA KOICHI ET AL		T	
	3	WO 01/48795	07/05/2001	KUMAR AJAY ET AL.			
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		NON-PATENT LITERATURE DOCUMENTS	NOTE OF S
Examiner Initials*	Cite No. ¹	Include name of the author (in capital letters), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T6
	1	FRITSCHI R ET AL: "A NOVEL RF MEMS TECHNOLOGICAL PLATFORM"; IECON-2002 PROCEEDINGS OF THE 28 TH ANNUAL CONFERENCE OF THE IEEE INDUSTRIAL ELECTRONICS SOCIETY"; SEVILLA SPAIN; NOV. 5-8, 2002; ANNUAL CONF. OF IEEE NEW YORK; VOL. 1 OF 4 CONF. 28; 11/5/2002; PP 3052-3056	
	2	CHANG C ET AL: "INNOVATIVE MICROMACHINED MICROWAVE SWITCH WITH VERY LOW INSERTION LOSS"; SENSORS AND ACTUATORS A, ELSEVIER SEQUOIA S.A. LAUSANNE; CH VOL. 79 NO. 1; JAN 2000; PP 71-75	

^{*} EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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